

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.:

Group Art Unit:

Inventors: Koenigsmann et al.

Filed:

Title: HIGH PURITY FERROMAGNETIC  
SPUTTER TARGET, ASSEMBLY  
AND METHOD OF MANUFACTURING SAME

Examiner:

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 CFR 1.51, 1.56 and 1.97 to 1.99, the list of references cited on the attached Form PTO-1449 is made of record to assist the Patent and Trademark Office in its examination of this application. A copy of the EP patent document is enclosed herewith. Since we have not received an Office Action on the merits, no fee is believed to be due.

This disclosure statement should neither be construed as a representation that a search has been made, nor as an admission that the information cited is, or is considered to be, material to patentability as defined in 1.56(b).

Respectfully submitted,



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Iurie A. Schwartz  
Attorney for Applicants  
Reg. No. 43,909

Praxair, Inc.  
39 Old Ridgebury Road  
Danbury, CT 06810-5113  
Phone: (203) 837-2115

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